



**COPY**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2892  
Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant	:	Akira TAKAHASHI	)	
			)	
Serial No.	:	10/798,482	)	<b><u>RESPONSE</u></b>
			)	
Filed	:	March 12, 2004	)	
			)	
For	:	DRY ETCHING METHOD FOR SEMICONDUCTOR DEVICE	)	
			)	
Attorney Ref.	:	OKI 414	)	

April 21, 2009

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action of January 21, 2009, the period for reply to which has been set to expire on April 21, 2009.

A fee of \$ None is being submitted concurrently. Should this remittance be accidentally missing, however, or should any additional fees be needed (including any extension of time fees, since Applicant hereby provisionally petitions for any extensions that may be deemed necessary to avoid abandonment), the Director may charge such fees to our Deposit Account number 18-0002.

Please reconsider the above identified application in view of the Remarks that are presented on the following pages.